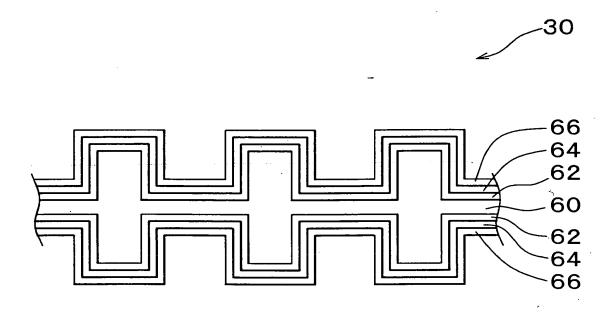
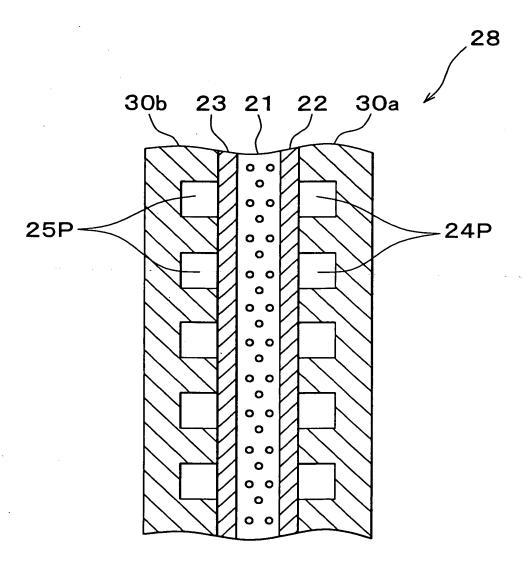
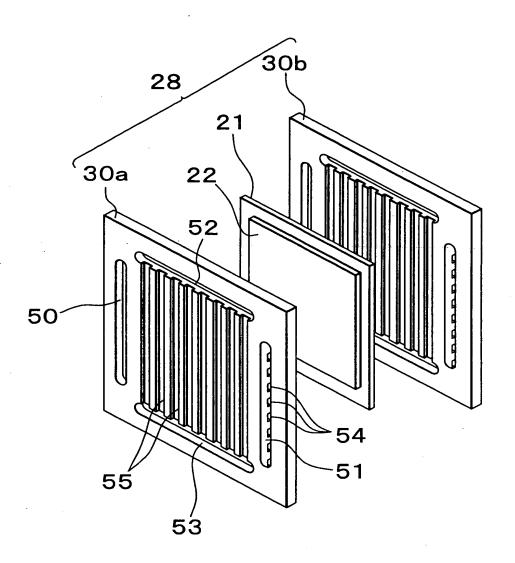
F I G. 1

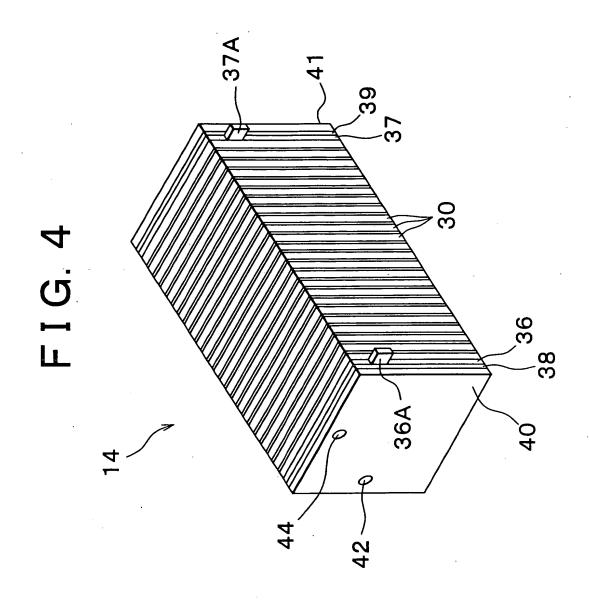


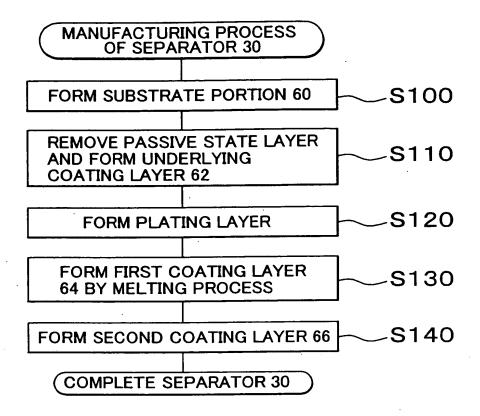
F I G. 2



F I G. 3







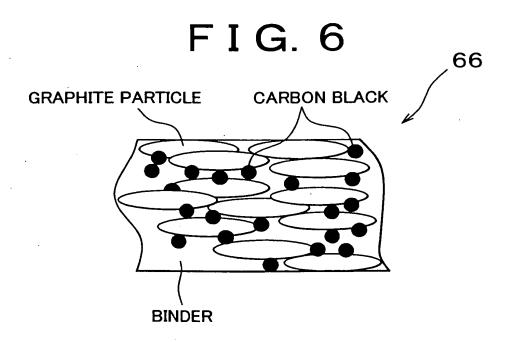


FIG. 7A

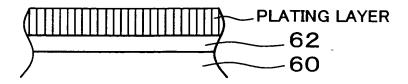
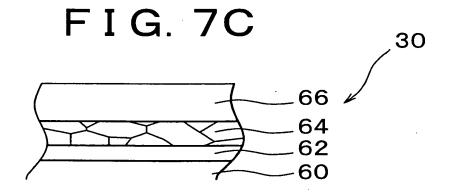
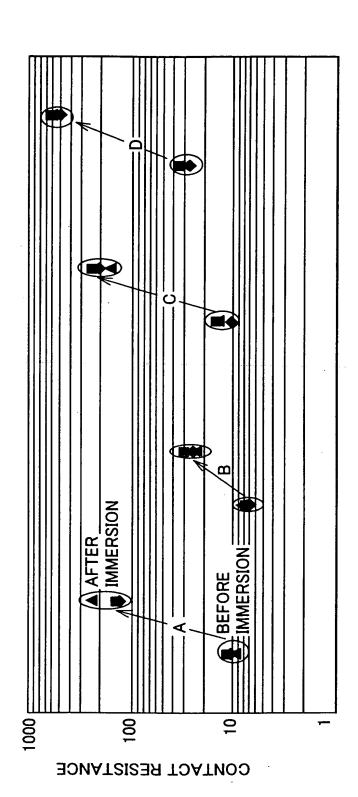


FIG. 7B





F I G. 8

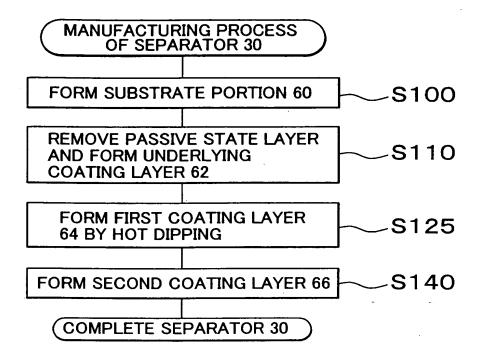


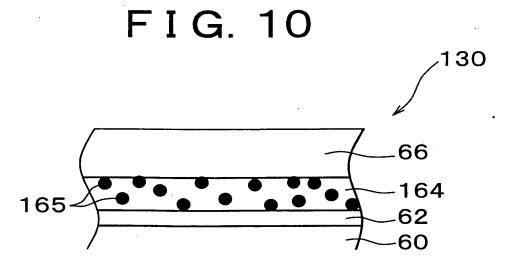
A: Sn-Bi, WITHOUT MELTING PROCESS

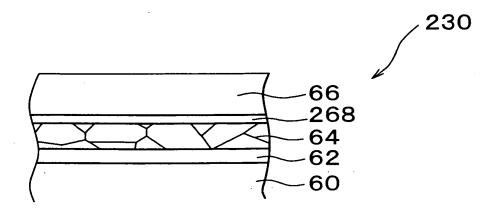
B:Sn-Bi, WITH MELTING PROCESS (AIR-COOLING) C:Sn-Bi, WITH MELTING PROCESS (WATER-COOLING)

WITH MELTING PROCESS (AIR-COOLING) D : Sn,

FIG. 9

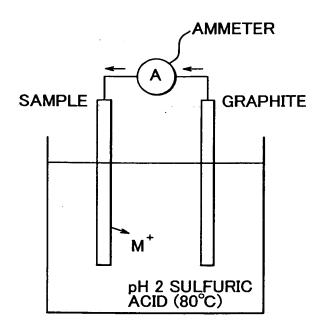






SURFACE TREATMENT	CORROSION CURRENT *1 (μ A/cm²)	CONTACT RESISTANCE *2 (mΩcm²)
E:0.1 μ mAg/10 μ mCu	6.9	10 OR LESS
F:0.1 μ mAg/10 μ mSn(UNPROCESSED) /10 μ mCu	21.9	10 OR LESS
G:0.1 μ mAg/10 μ mSn(MELTING PROCESS) /10 μ mCu	0.3	10 OR LESS

- * 1: RESULT OBTAINED WITHOUT CARBON COATING LAYER OF CARBON MATERIALS
- * 2: RESULT OBTAINED WITH CARBON COATING LAYER OF CARBON MATERIALS



SEPARATOR P BASE MATERIAL* P	PREDETER MINED PROCESS*	METAL COATING LAYER*	CONDUCTIVE PARTICLES*	CORROSION -RESISTANT COATING LAYER*	CARBON CORTING LAYER*
PRESENT	PRESENT	METAL HAVING LOWER MELTING POINT THAN MATERIAL OF SEPARATOR BASE MATERIAL AND HAVING BEEN SUBJECTED TO MELTING PROCESS OR METAL HAVING CRYSTAL GRAIN SIZE OF 0.1 mm	PRESENT	PRESENT	PRESENT
		OR MORE			

* : ANY MATERIAL AS DESCRIBED IN THE SPECIFICATION CAN BE SELECTED AS APPROPRIATE